## Notice of References Cited Application/Control No. 10/039,009 Examiner Eleni A Shiferaw Applicant(s)/Patent Under Reexamination LIN, ZHI-HAO Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,138,239 A	10-2000	Veil, Leonard Scott	713/200
	В	US-2003/0084278 A1	05-2003	Cromer et al.	713/2
	С	US-6,463,550 B1	10-2002	Cepulis et al.	714/25
	D	US-6,223,283 B1	04-2001	Chaiken et al.	713/1
	Е	US-5,892,906 A	04-1999	Chou et al.	713/202
	F	US-6,564,318 B1	05-2003	Gharda et al.	713/2
	G	US-6,009,520 A	12-1999	Gharda, Laurent Kirk	713/1
	Н	US-			
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N			-		
	0		•			
	Р				,	
	Q					
	R					
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	·
	V	
	w	·
	x	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.